CLIPPEDIMAGE= JP403209885A

PAT-NO: JP403209885A

DOCUMENT-IDENTIFIER: JP 03209885 A TITLE: PIEZOELECTRIC BIMORPH ELEMENT

PUBN-DATE: September 12, 1991

INVENTOR-INFORMATION:

NAME

MATSUMURA, TAKENOBU

ASSIGNEE-INFORMATION:

NAME

UBE IND LTD

COUNTRY N/A

APPL-NO: JP02003640

APPL-DATE: January 12, 1990

INT-CL_(IPC): H01L041/09
US-CL-CURRENT: 310/330

ABSTRACT:

PURPOSE: To enable a piezoelectric bimorph element to

reliably transmit an

actuating action over a long time by a method wherein an

electrical insulating

band is provided onto a piezoelectric board to separate an

action transmitting

section from an electrode section.

CONSTITUTION: Two piezoelectric plates 1 and 4 and a shim material 7 are pasted

together to constitute a piezoelectric bimorph element, surface electrodes 2a,

2b, 6a, and 6b are provided onto both the sides of the two piezoelectric

plates, and action transmitting sections 3 and 5 are isolated from the surface

electrodes 2a and 2b through an electric insulating band 10. By this setup, a

metal film electrically conductive and abrasion-resistant such as an Ni metal

film can be formed on the action transmitting section and the electrode

section, a bimorph driving high voltage is prevented from

leaking to other electric circuits or mechanical components even if an actuated object is an electrically conductive piece formed of metal, operating parts are hardly cut or broken down, and thus a piezoelectric bimorph element of this design is able to reliably transmit an actuator action over for a long time.

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CLIPPEDIMAGE= JP403064081A

PAT-NO: JP403064081A

DOCUMENT-IDENTIFIER: JP 03064081 A TITLE: PIEZOELECTRIC BIMORPH ELEMENT

PUBN-DATE: March 19, 1991

INVENTOR-INFORMATION:

NAME

MATSUMURA, TAKENOBU

ASSIGNEE-INFORMATION:

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UBE IND LTD

COUNTRY

N/A

APPL-NO: JP01198034

APPL-DATE: August 1, 1989

INT-CL_(IPC): H01L041/09
US-CL-CURRENT: 310/330

ABSTRACT:

PURPOSE: To prevent an actuator driving high voltage from leaking to other

mechanical element or an electric circuit and to accurately transmit the

operation of a piezoelectric bimorph element to an element to be operated for a

long period by providing an electrically insulating ceramic unit on an

operation transmitter of a piezoelectric ceramic plate.

CONSTITUTION: A piezoelectric bimorph element is composed by adhering

piezoelectric ceramic plates 1A, 1B on which electrodes 3 are arranged, through

a shim material 2. One end is secured by a securing member 5, and the other

end is formed as an operation transmitting member in which an electrically

insulating ceramic unit 4 of a small area is formed on a prezoelectric ceramic

plate or an electrode on the ceramic plate. The ceramics include, for example,

silica, alumina, silicon nitride, lead borosilicate glass,

etc. In order to alleviate warpage of the ceramic plate after a thin film is formed, the ceramic material is preferably so selected as to reduce thermal expansion coefficient difference of the insulating ceramics and the piezoelectric ceramic plates as small as possible.

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